

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT3861693

SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	
CONVEYING PARTY DATA		
	Name	Execution Date
	DE MONTFORT UNIVERSITY	02/05/2010
RECEIVING PARTY DATA		
Name:	WZVI LIMITED	
Street Address:	ONE VINE STREET	
City:	LONDON	
State/Country:	UNITED KINGDOM	
Postal Code:	W1J 0AH	
PROPERTY NUMBERS Total: 1		
	Property Type	Number
	Patent Number:	6856824
CORRESPONDENCE DATA		
Fax Number:	(202)756-8087	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>		
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Correspondent Name:	MCDERMOTT, WILL & EMERY LLP	
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ATTORNEY DOCKET NUMBER:	077165-0040	
NAME OF SUBMITTER:	MATTHEW J. GRYZLO	
SIGNATURE:	/Matthew J. Gryzlo/	
DATE SIGNED:	05/06/2016	
Total Attachments: 16 source=Assignment-1#page1.tif source=Assignment-1#page2.tif source=Assignment-1#page3.tif source=Assignment-1#page4.tif source=Assignment-1#page5.tif source=Assignment-1#page6.tif source=Assignment-1#page7.tif		

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DATED 05 / 02 2010

(1) DE MONTFORT UNIVERSITY

and

(2) WZVI LIMITED

PATENT RIGHTS ASSIGNMENT AGREEMENT
re EIM / CEIMUS PATENTS

Execution

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(1) DE MONTFORT UNIVERSITY

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Execution

PATENT RIGHTS ASSIGNMENT AGREEMENT entered into as a Deed dated2010

BETWEEN:

- (1) **DE MONTFORT UNIVERSITY** of The Gateway, Leicester LE1 9BH ('**De Montfort University**');
and
- (2) **WZVI LIMITED** a private limited company incorporated and registered in England and Wales with company number 06651969 whose registered office is at One Vine St, London, W1J 0AH United Kingdom ('**WZVI**').

WHEREAS:

- (A) De Montfort University is the owner of or (as applicable) applicant for the Patent Rights.
- (B) De Montfort University has agreed to assign the Patent Rights to WZVI on the terms set out in this assignment.

IT IS AGREED as follows:

1 INTERPRETATION

In this assignment:

'**Inventions**' means the subject matter of the Patent Rights;

'**Patent Rights**' means the patents or patent applications listed in Schedule 1 and any other patent application which may be made after the date of this assignment in any part of the world in respect of the same subject matter as any of the Patent Rights, and any patent granted or issued in pursuance of any of the Patent Rights or such other patent application (including any division or extension of any of them);

2 ASSIGNMENT

For the consideration referred to in clause 3, and otherwise on the terms of this assignment, De Montfort University hereby assigns to WZVI absolutely and with full title guarantee, free from all liens, options, charges, licences or other encumbrances, all the property, right, and interest in and to the Patent Rights and the Inventions including:

- (a) the absolute entitlement to any patents granted pursuant to any of the applications comprised in the Patent Rights for the full term of such patents;
- (b) the right to apply for, prosecute and obtain patent or other protection in any part of the world in respect of any of the Inventions, all rights to any continuations, continuations in part, extensions, reissues and divisions, any supplementary protection certificates and similar rights which are based on or derive priority from any of the foregoing and the right to claim priority from any such application; and
- (c) the right to sue for and take all such proceedings as may be necessary for the recovery of damages or otherwise in respect of all infringements of any of the Patent Rights, whether committed before or after the date of this assignment.

3 CONSIDERATION

As consideration for the assignment under clause 2, WZVI shall issue and allot to De Montfort University, 100 ordinary shares of £1 each in the capital of WZVI, credited as fully paid, and ranking pari passu with the existing ordinary shares of £1 each in the capital of WZVI.

4 FURTHER ASSURANCE

- 4.1 De Montfort University shall at the cost of WZVI at any time at the reasonable request of WZVI execute all such further documents in a form acceptable to WZVI and do all such things as may be necessary to vest in WZVI the full benefit of the items assigned under clause 2 and render all necessary assistance to WZVI in prosecuting, maintaining and defending the Patent Rights.
- 4.2 Without limiting clause 4.1, De Montfort University shall on the execution of this assignment deliver to WZVI true and complete copies of all correspondence with patent attorneys relating to the Patent Rights which are in the possession or control of De Montfort University, together with all such forms as are necessary to register the transfer of the Patent Rights, duly signed on behalf of De Montfort University.

4 WARRANTIES

De Montfort University warrants, represents and undertakes to WZVI that:

- (a) the facts set out in Schedule 1 regarding the Patent Rights are true, complete and accurate;
- (b) it is not aware of any reason why any applications comprised in the Patent Rights should not proceed to grant or be issued in any country or territory;
- (c) no agreements, arrangements or understandings have been entered into by it with any person in relation to, or to grant to any person any licence or other rights in respect of, any Invention or any of the Patent Rights;
- (d) it is not aware of any infringement of any of the Patent Rights or of anything that would be such an infringement if the Patent Rights had been granted or issued prior to the date of this assignment; and
- (e) it is not aware of any allegation that the Inventions have infringed or are likely to infringe the intellectual property or other rights of any person.

5 GENERAL

- 5.1 This assignment may be executed in two or more counterparts each of which will be an original part of this assignment.
- 5.2 This assignment and any dispute or claim arising out of or in connection with it or its subject matter or formation (including non-contractual disputes or claims) shall be governed by and construed in accordance with the law of England.
- 5.3 The parties irrevocably agree that the courts of England and Wales shall have exclusive jurisdiction to settle any dispute or claim that arises out of or in connection with this assignment or its subject matter or formation (including non-contractual disputes or claims).

IN WITNESS WHEREOF this assignment has been executed and delivered as a Deed on the date first above written.

SCHEDULE 1

The Patent Rights

	Title	Claim 1	Country	Application No. / Patent No.	Status
1	Apparatus and Method for Electrical Impedance Imaging	<i>"Apparatus for electrical impedance imaging of an object, the apparatus comprising first and second electrode arrangements spaced apart to define an imaging region there between, an object to be imaged being locatable, in use, in the imaging region so that impedance data can be collected from the object using the first and second electrode arrangements to permit the construction of an impedance image of the object."</i>	Europe	European patent application number 07712927.8	Pending
2	Apparatus and Method for Electrical Impedance Imaging	As in 1 above	China	China patent application number 20078021865	Pending
3	A Method for Analysing the Structure of an Electrically Conductive Object	<i>"A method for analysing the structure of an electrically conductive object, the method comprising the steps of: (i) obtaining electrical impedance data for the object over a range of frequencies; (ii) analysing the obtained electrical impedance data using a transfer function of an assumed electrical model to determine a plurality of electrical impedance properties for the object; (iii) constructively combining selected ones of the determined plurality of electrical impedance properties to provide at least one parametric impedance value for the object; and (iv) imaging one or more of the determined parametric impedance values."</i>	International	International patent application number PCT/GB2008/001982	Pending

4	A High-Frequency Current Source for Electrical Impedance Tomography (EIT), with Compensation for Amplifier Gain Error	<i>A voltage controlled current source comprising: (i) a voltage input node for receiving an input voltage, a current output node for providing a constant current to a load; (ii) an operational amplifier having a gain and comprising a first amplifier input node, a second amplifier input node and an amplifier output node, a first resistor connected between the voltage input node and the second amplifier input node; (iii) a second resistor connected between the amplifier output node and the second amplifier input node; (iv) a third resistor connected between a reference voltage and the first amplifier input node; (v) a fourth resistor connected between the current output node and the first amplifier input node; (vi) a fifth resistor connected between the amplifier output node and the current output node, wherein one or more of the first, second, third, fourth or fifth resistors is a variable resistor; and (vii) compensation means, configured to compensate for frequency dependent variation of the amplifier gain by controlling the value of one or more of the first, second, third, fourth or fifth resistors."</i>	United Kingdom	United Kingdom patent application number 0710950.7	Pending
5	An Apparatus and Method for Non-Contact Electrical Impedance Imaging	<i>"A method of electrical impedance imaging using multiple recessed electrodes in which each of the multiple electrodes does not contact the object to be imaged but is electrically coupled to the object via electrically conductive fluid in which the object is at least partially immersed."</i>	Europe	European patent application number 06765197.6,	Pending


6	An Apparatus and Method for Non-Contact Electrical Impedance Imaging	As in 5 above	Japan	Japan patent application number 20080524585	Pending
7	An Apparatus and Method for Non-Contact Electrical Impedance Imaging	As in 5 above	Korea	Korea patent application number 1020087005487	Pending
8	Apparatus for Detecting Abnormalities in Bodily Matter	<i>"An electrical tomographic method for detecting abnormalities in bodily matter comprising the steps of: generating electrical signals having a frequency greater than 4 MHz; applying the electrical signals to the bodily matter using an electrode arrangement; detecting electrical impedance properties of the bodily matter; and, using data processing means correlating the detected electrical impedance properties with the presence or absence of abnormalities in the bodily matter using a fractal model of tissue impedance."</i>	United States	United States patent number 6,856, 824	Granted 15 February 2005
9	Apparatus for Detecting Abnormalities in Bodily Matter	As in 8 above	China	Chinese patent number 100335003	Granted
10	Apparatus for Detecting Abnormalities in Bodily Matter	As in 8 above	Japan	Japan patent application number 20000567132T	Pending
	Apparatus for Detecting Abnormalities in Bodily Matter	As in 8 above	Hong Kong	Hong Kong patent application number 20020101416	Pending

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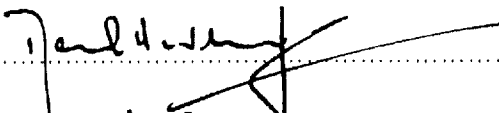
DE MONTFORT UNIVERSITY

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Authorised Signatory

In the presence of:

Witness Signature


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WITNESS

Witness Name

Witness Address

90 de Montfort Univ
Leicester
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EXECUTED as a Deed by

WZVI LIMITED

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Director

In the presence of:

Witness Signature

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Witness Name

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DATED 05 / 02 2010

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DE MONTFORT UNIVERSITY)
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Authorised Signatory

In the presence of:

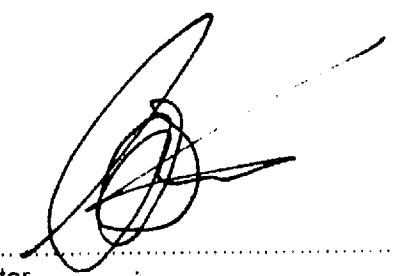
Witness Signature

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Director

In the presence of:

Witness Signature

Witness Name

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